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ROYLANCE ABRAMS

FILE

TATENT

46379

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takashi FUJII et al.

Group Art Unit: 1762

Serial No.: 10/784,211

ATTN: OFFICE OF INITIAL PATENT EXAMINATION'S

Filed: February 24, 2004

FILING RECEIPT CORRECTIONS

For:

PROCESS FOR PRODUCING COLD

FIELD EMISSION CATHODES

FAX NO.: (703) 746-9195

REQUEST FOR CORRECTION OF FILING RECEIPT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants request that the filing receipt be corrected to indicate the correct foreign application information in the subject application. The filing receipt indicates the incorrect Japanese application in the "Foreign Applications" section of the filing receipt. The correct application from which the subject application claims priority is:

Japan 2003-049195 02/26/2003

Attached hereto is a marked-up copy of the Filing Receipt noting the requested correction. Accordingly, Applicant hereby requests a Corrected Filing Receipt be issued.

Respectfully submitted,

Garrett V. Davis

Reg. No. 32,023

Roylance, Abrams, Berdo & Goodman, L.L.P. 1300 19th Street, N.W., Suite 600 Washington, D.C. 20036 (202) 659-9076

PAGE 1/2* RCVD AT 7/29/2004 10:37:41 AM [Eastern Daylight Time] * SVR:USPTO-EFXRF-2/1* DNIS:7469195 * CSID:2026599344 * DURATION (mm-ss):01-02



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10/784 211	02/24/2004	1762	1022	46379	4	34	3

CONFIRMATION NO. 8414

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ROYLANCE, ABRAMS, BERDO & GOODMAN, L.L.P.
1300 19TH STREET, N.W.
SUITE 600
WASHINGTON,, DC 20036

FILING RECEIPT

OC000000012876311

Date Mailed: 05/17/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s) :

Takashi Fujii, Tsukuba-shi, JAPAN; Masao Someya, Tsukuba-shi, JAPAN;

Domestic Priority data as claimed by applicant

Foreign Applications

--- JAPAN 2000-154335-05/22/2000-

JAPAN 2003-049195 02/26/2003

If Required, Foreign Filing License Granted: 05/14/2004

Projected Publication Date: 08/26/2004

Non-Publication Request: No

Early Publication Request: No

Title

Process for producing cold field-emission cathodes

Preliminary Class